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3732/15

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Densen Cao

Examiner: Ralph A. Lewis

Serial Number: 10/017,454

Group Art Unit: 3732

Filed: December 13, 2001

For: "Improved Semiconductor Curing Light System Useful for Curing Light Activated Composite Materials"

DOCKET: 5061 P

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

Honorable Commissioner:


Applicant received an Office Action with a mailing date of June 30, 2005. with a three (3) months period permitted for a response. Applicant hereby petitions for a three (3) month extension of time in which to file a response. This extends the time for response through December 30, 2005.

Please charge the required fees of One Thousand Twenty Dollars (\$1,020.00) to our Deposit Account No. 50-0581.

Respectfully submitted this 30th day of December, 2005.

01/04/2006 HDESTA1 00000043 500581 10017454

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